## **Measurement & Inspection Solutions for High-Precision Applications**

Ergonomic

# Precision Accuracy

Submicron Applications

## **MIRAGE®**

Non-Contact Automatic 3-Axis
Vision and Laser Based Tableton
Measurement System

#### **PRECISION AND ACCURACY**

The Mirage® automatic vision and laser measurement system provides high accuracy measurement in a compact tabletop model. A typical configuration may include microscope optics using a two-position precision automatic lens shuttle. Laser auto focus can be added for high speed, on-the-fly focusing of the video image. An optional laser probe is available for ultra-precise Z-axis profiling.

#### **FEATURES**

- Micron-Scale Accuracy, Submicron Resolution
- JMAR VideoCMM ® Software for Windows 7\*
- Supports High Magnification Microscope Optics
- Automatic Two-Position Lens Shuttle (Optional)
- Three Channel Computer-Controlled Light Source
- Laser Auto Focus (Optional)
- Z-Axis Laser Probes (Optional)
- Integrated Active Air Isolation (Optional)
- Integrated Active Air Isolation

#### **OPTIONS**

Dual position automatic lens shuttle Lens change speed: < 1 second Lens repeatability: <  $1\mu m$ 

Dynamic laser auto focus

High precision scanning laser probes

Working distance: 5 to 30 mm

Spot size: 1 to  $15\mu m$ Resolution: .03 to  $1\mu m$ 

Active air vibration isolation

Fiber optic ring light Brightfield / Darkfield

Differential Interface Contrast (D.I.C.)



ISO 9001 Certified www.ppli.com



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High magnification platform stability, stage accuracy, and high resolution make the Mirage® the perfect choice for measurement and process control. This system is ideal for inspection of such parts and components as:

- ◆ TAB-tape
- Ball grid arrays (BGA)
- → Flex circuits
- Head gimbal assemblies (HGA)
- + Lead frames
- Sliders (pole tip and gap measurement)
- Wire bonding (weld bonds or ball bonds)
- Wire loop height
- Wafer critical dimensions (CD)

\*Windows XP is a trademark of Microsoft Corporation

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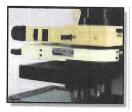
#### **Optical Flexibility**

- · Micro or macro lenses
- Brightfield / Darkfield (Optional)
- · Up to 100x objectives
- Effective magnification to 3000x

#### Laser Probe Mounted Next to Video (Optional)

- · High resolution Z-axis profiling
- · Single point and scanning applications
- Triangulation or active focus laser probes





#### **5 Position Turret**

- High speed auto focus
- Computer controlled
- · Computer programmable offsets

#### 3-Light Lamp Source

- · Digital computer control
- · Independently controlled channels





#### Automatic Two-Position Lens Shuttle (Optional)

- · Manual or computer controlled
- · Supports micro or macro optics
- Supports ring light

#### Mechanical Specifications:

X-Y stage travel: 10" x 4" Fine focus Z-axis travel: 2" Manual Z-height adjust: 8"

Size: 22"x30"x33"LWH Weight: 250 lbs (114 kg) Electrical Specifications:

120vac/220VAC compatibility

Max. Current: 20A

Optical: Supports major brands of optical systems

Micro or macro optics

Up to 3000x total magnification.

Passive Vibration Isolation

Illumination Sources:

3 Channel digital light control

Transmitted, incident and optional oblique lighting

Computer Hardware:

IBM Pentium class compatible PC

SVGA color monitor

Stage Resolution and Accuracy:

Resolution: .1μm Repeatability: < 1μm

Accuracy: 3µm (see detailed specification)

Accuracy: - in µm

U1 = (2.0 + L/100 (XY PLane) U2 (Z Axis) = (2.0 + L/20)

Where L is the Length in mm.

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Specifications subject to change without notice

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Printed in USA